

CS-03-021



Serial No. 10/688,047

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IPW

November 10, 2005

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Fr: Stephen B. Ackerman, Reg. No. 37,761
28 Davis Avenue
Poughkeepsie, N.Y. 12603

Subject:

Serial No.	10/688,047	10/17/03
C. F. TAN ET AL		
"END OF RANGE (EOR) SECONDARY DEFECT ENGINEERING USING CHEMICAL VAPOR DEPOSITION (CVD) SUBSTITUTIONAL CARBON DOPING"		
Grp. Art Unit: 2822	MARIA F. GUERRERO	

*Entered
w/ack
1-3-06
Dunne
1-10-06*

RESPONSE FINAL PATENT OFFICE ACTION

Dear Sir:

In response to the Final Office Action dated September 28, 2005, please amend the
above-identified application for patent as follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal
Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box
1450, Alexandria, VA 22313-1450, on November 10, 2005.

Rosemary L. S. Pike. Reg # 39,332

Signature Rosemary L. S. Pike
Date 11/10/05